

Rev. 1-10-03

Effective March 1998

DECLARATION AND POWER OF ATTORNEY FOR U.S. PATENT APPLICATION

() Original () Supplemental () Substitute (X) PCT () DESIGN

As a below named inventor, I hereby declare that: my residence, post office address and citizenship are as stated below next to my name; that I verily believe that I am the original, first and sole inventor (if only one name is listed below) or an original, first and joint inventor (if plural inventors are named below) of the subject matter which is claimed and for which a patent is sought on the invention

Title: STRUCTURES SELECTING	G METHOD FOR CARBON NANOTUI	BES BY LIGHT IRRADIATION		
of which is described and claimed i () the attached specification, or () the specification in application So, or (X) the specification in Internationa (if applicable).	n: rial No, filed <u>Januar</u> I Application No. <u>PCT/JP03/04182</u> , filed	y 18, 2005, and with amendments April 1, 2003, and as amended o	s throughn	
any amendment(s) referred to above	nd understand the content of the above-id	lentified specification, including t	he claims, as amended	d by
acknowledge my duty to disclose to n Title 37, Code of Federal Regulati	the Patent and Trademark Office all informons, §1.56.	nation known to me to be material	to patentability as defi	ned
hereby claim priority benefits under or patent or inventor's certificate list iling date before that of the applicati	Title 35, United States Code, §119 (and § ed below and have also identified below on on which priority is claimed:	172 if this application is for a Des any application for patent or inve	ign) of any application ntor's certificate havin	ı(s) ıg a
COUNTRY	APPLICATION NO.	DATE OF FILING	PRIORITY CLAIMED	
Japan	2003-000718	January 6, 2003	Yes	

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Japan	2003-000718	January 6, 2003	Yes

I hereby claim the benefit under Title 35, United States Code §120 of any United States application(s) listed below and, insofar as the subject matter of each of the claims of this application is not disclosed in the prior United States application in the manner provided by the first paragraph of Title 35, United States Code §112, I acknowledge the duty to disclose information material to patentability as defined in Title 37, Code of Federal Regulations, §1.56 which occurred between the filing date of the prior application and the national or PCT international filing date of this application:

APPLICATION SERIAL NO.	U.S. FILING DATE	STATUS: PATENTED, PENDING, ABANDONED
		I SAN DONED

And I hereby appoint Michael R. Davis, Reg. No. 25,134; Matthew M. Jacob, Reg. No. 25,154; Warren M. Cheek, Jr., Reg. No. 33,367; Nils Pedersen, Reg. No. 33,145; Charles R. Watts, Reg. No. 33,142; Michael S. Huppert, Reg. No. 40,268; and Jeffrey R. Filipek, Reg. No. 41,471, who together constitute the firm of WENDEROTH, LIND & PONACK, L.L.P., as well as any other attorneys and agents associated with Customer No. 000513, to prosecute this application and to transact all business in the U.S. Patent and Trademark Office

I hereby authorize the U.S. attorneys and agents named herein to accept and follow instructions from NISHIZAWA & ASSOCIATES as to any action to be taken in the U.S. Patent and Trademark Office regarding this application without direct communication between the U.S. attorneys and myself. In the event of a change in the persons from whom instructions may be taken, the U.S. attorneys named herein will be so notified by me.

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I further declare that all statements made herein of my own knowledge are true, and that all statements on information and belief are believed to be true; and further that these statements were made with the knowledge that willful false statements and the like so made are punishable by fine or imprisonment, or both, under Section 1001 of Title 18 of the United States Code, and that such willful false statements may jeopardize the validity of the application or any patent issuing thereon.

Sumio IIIIMA	Date March 3, 2005
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4th Inventor	Date
5th Inventor	Date
6th Inventor	Date
. The above application may be more particularly identi	fied as follows:
U.S. Application Serial No Fil	
Applicant Reference Number <u>02-F-069US/NT</u> Atty I	

Title of Invention STRUCTURES SELECTING METHOD FOR CARBON NANOTUBES BY LIGHT IRRADIATION